

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DAVID J. BAIN, ET AL.)
Serial No.: 10/710,653) Group Art Unit: 2836
Filed: July 27, 2004)
For: PRESSURE ASSISTED WAFER)
HOLDING APPARATUS AND)
CONTROL METHOD) Examiner: Roman, L.
) Confirmation No.: 4652
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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed October 10, 2006, please amend the Application as follows: